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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hongyong ZHANG et al.

Serial No. 09/633,869

Filed: August 7, 2000

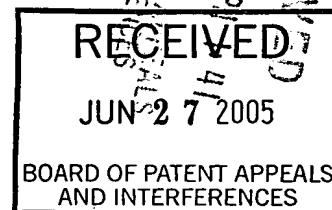
For: METHOD FOR LASER-PROCESSING
SEMICONDUCTOR DEVICE

Examiner: Victor SIMKOVIC

Group Art Unit: 2812

CORRECTED INFORMATION DISCLOSURE STATEMENT

Mail Stop
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir:

In reviewing the above application, applicants noted a minor typographical error on the PTO-1449 submitted with the Information Disclosure Statement filed on August 5, 2004. In regards to JP03-286518, the Full Translation was submitted not the Abstract. In order to assist the Examiner, Applicants submit herewith a copy of the JP03-286518 and full translation.

It is requested that the above publication be crossed-through on the PTO-1449 filed on August 5, 2004 and the attached PTO-1449 be considered and made of record in the above-identified application. It is respectfully requested that an Examiner initial a copy of this form and return it to the undersigned.

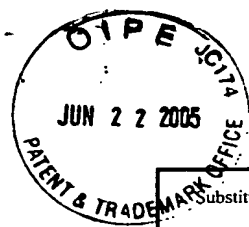
The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By:

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known			
				Application Number		09/633,869	
				Filing Date		August 7, 2000	
				First Named Inventor		Hongyong ZHANG et al.	
				Art Unit		2812	
				Examiner Name		Victor SIMKOVIC	
Sheet	1	Of	1	Attorney Docket Number		740756-2100	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
		JP-03-286518	December 17, 1991	HASHIZUME		FULL

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.